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**INFORMATION DISCLOSURE  
STATEMENT BY APPLICANT**

(use as many sheets as necessary)

Complete if Known 04517657

Application Number	Not yet assigned
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Art Unit	Not yet assigned
Examiner Name	Not yet assigned
Attorney Docket Number	Q85169

Sheet 1 of 1

**U.S. PATENT DOCUMENTS**

Examiner Initials*	Cite No. <sup>1</sup>	Document Number		Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document
		Number	Kind Code <sup>2</sup> (if known)		
/MS/		US 2002/050711	A1	05/2/2002	Waiti, et al.
/MS/		US 2002/022682	A1	09/20/2001	McClelland
/MS/		US 5,487,012		01/23/1996	Tophelm et al.

**FOREIGN PATENT DOCUMENTS**

Examiner Initials*	Cite No. <sup>1</sup>	Foreign Patent Document			Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Translation <sup>6</sup>
		Country Code <sup>3</sup>	Number <sup>4</sup>	Kind Code <sup>5</sup> (if known)			
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/MS/		WO	02/091920		11/21/2002	OTICON AS	

**NON PATENT LITERATURE DOCUMENTS**

Examiner Initials*	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city, and/or country where published.	Translation <sup>6</sup>
/MS/		Xie Huikai et al.: "A SCS SMOS Micromirror for Optical Coherence Tomographic Imaging" Technical Digest., MEMS 2002 IEEE International Conference on Micro Electro Mechanical Systems, Las Vegas, NV, USA, January 20, 2002-January 24, 2002, pages 495-498, XP010577701, Piscataway, NJ, USA, ISBN: 0-7803-7185-2, pages 497-487, section "OCT application" abstract	
/MS/		J. Micromech. Microeng. 13, 2003, pages 383-389	

Examiner Signature

/Michael Stafira/

Date Considered

06/08/2007

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